



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

## PATENT APPLICATION

LEBOUITZ ET AL.

APPARATUS FOR ETCHING SEMI-  
CONDUCTOR SAMPLES AND A  
SOURCE FOR PROVIDING A GAS  
BY SUBLIMATION THERETO

Serial No. 09/839,763

Filed April 20, 2001

INFORMATION DISCLOSURE STATEMENT

Pittsburgh, Pennsylvania 15222

November 1, 2002

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. §§1.51, 1.56, 1.97 and 1.98, a copy of the art identified on attached form PTO-1449 is enclosed herewith as a citation in connection with the captioned application. The applicants hereby request the Examiner to review and make an independent evaluation of the art. A copy of each reference is provided.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on:

November 1, 2002  
Date of Deposit

Philip E. Levy, Esq.  
Name of Person Signing

  
Signature

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Mitsubishi Electric Corp., Japanese Patent No. 10 209088

No fee is believed to be required in connection with the filing of this Information Disclosure Statement since it is being filed in compliance with 37 C.F.R. §1.97(b)(3), before the mailing of a first Office Action on the merits of the above-captioned application. In addition, if an Office Action has been mailed, but not yet received, no fee is due since the Information Disclosure Statement would comply with 37 C.F.R. §197.(c) because I hereby certify that the information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Applicants believe that their APPARATUS FOR ETCHING SEMICONDUCTOR SAMPLES AND A SOURCE FOR PROVIDING A GAS BBY SUBLIMATION THERETO as described and claimed in the present application is neither taught nor suggested by this prior art. Accordingly, applicants' invention is believed to be patentable over these prior art references.

Respectfully submitted,

METZ LEWIS LLC



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